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ATTORNEY DOCKET NUMBER: 40296-0025

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	Ho Jin CHO et al.	Group Art Unit:	2812
Serial Number:	10/608,103	Examiner:	Jennifer M. KENNEDY
Filing Date:	June 30, 2003	Confirmation No.:	1058
For:	Method For Forming Capacitor of Semiconductor Device		

AMENDMENT AND REPLY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action, mailed November 18, 2004 in the above-captioned patent application, Applicants request entry of the following amendment and consideration of the following remarks: